

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: (Divisional of 09/853,090)
Filing Date: Herewith
Applicant: Yoshiaki EMOTO
Group Art Unit: 2827
Examiner: Luan C. Thai
Title: SEMICONDUCTOR DEVICE AND METHOD FOR
MANUFACTURING THE SAME
Attorney Docket: 9319S-208DVA

Director of the United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with the statutory provisions set forth in 37 CFR § 1.97 and 1.98, the Examiner is hereby respectfully advised of the references listed on the attached PTO-1449 Form. All of these references were made of record during prosecution of the parent application from which this divisional claims priority.

The listed references are cited only in the interest of candor and without any admission that they constitute statutory prior art, or contain matter which anticipates the invention or which would render the same obvious, either singly or in combination, to a person of ordinary skill in the art.

Respectfully submitted,

Dated: September 18, 2003

By: 

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FORM HDP-1449 (Based on Form PTO-1449) PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) Sheet 1 of 1	ATTORNEY DOCKET NO.	SERIAL NO.
	9319S-208DVA	
	APPLICANT	
	Yoshiaki EMOTO	
	FILING DATE	GROUP
	Herewith	2827

U.S. PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.		6,147,401	Nov/2000	Solberg, Vernon		

FOREIGN PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation * Yes No
1.		11-135537	May/1999	Japan		
2.		10-005221	Jan/1998	Japan		
3.		09-331599	Dec/1997	Japan		

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)		
Ref. Desig.	Examiner's Initials	
1.		

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Examiner:	Date Considered:
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